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New Insights into the Diverse Electronic Phases of a Novel Vanadium Dioxide Polymorph: A Terahertz Spectroscopy Study

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A remarkable feature of vanadium dioxide is that it can be synthesized in a number of polymorphs. The conductivity mechanism in the metastable layered polymorph $VO_2(B)$ thin films has been investigated by terahertz time-domain spectroscopy (THz-TDS). In $VO_2(B)$, a critical temperature of 240 K marks the appearance of a non-zero Drude term in the observed complex conductivity, indicating the evolution from a pure insulating state towards a metallic state. In contrast, the THz conductivity of the well-known $VO_2(M1)$ is well fitted only by a modification of the Drude model to include backscattering. We also identified two different THz conductivity regimes separated by temperature in these two polymorphs. The electronic phase diagram is constructed, revealing that the width and onset of the metal-insulator transition in the *B* phase develop differently from the *M*1 phase.

which with the same chemical composition, show great promise as future electronic materials. This is because their structural diversity can give rise to a variety of electrical and optical responses that can be tuned for technological applications such as optical switches, batteries, solar cells, optical filters, spintronic devices, memory devices etc¹⁻⁴. Vanadium dioxide is one of the most popular polymorphic materials that can assume several crystallographic structures⁵⁻⁷. Amongst the several stable and metastable VO₂ polymorphs, monoclinic VO₂(B) and monoclinic VO₂(M1) are particularly interesting, as these materials display more than thousand-fold changes in conductivity with temperature^{8.9}. Understanding polymorphism in vanadium dioxide has tremendous practical importance in the design and control of electro-optic materials for future technologies.

The metastable monoclinic VO₂(*B*) adopts a structure derived from V₂O₅ and belongs to the space group *C2/m* (12) compared to the well-known VO₂(*M*1), which takes up the space group *P2*₁/*c* (14)¹⁰⁻¹². The crystal structure of VO₂(B) is illustrated in Figure 1(a). A salient structural difference between the monoclinic phases in VO₂(*B*) and VO₂(*M*1) is that VO₂(*B*) has a smaller β inter-axial angle¹¹ ($\beta_{vo_2(B)} = 106.6^{\circ}$ and $\beta_{vo_2(M1)} = 122.6^{\circ}$) which may play an important role in the formation of defects and impurities in epitaxial growth of films. While metal-insulator transition (MIT) in VO₂(*M*1) is associated with a corresponding reversible structural phase transition from a room temperature monoclinic to a high temperature tetragonal phase^{9,13-16}, currently there is little understanding of the nature of the semimetal-to-insulator transition in VO₂(*B*) which remains monoclinic with MIT¹⁰. It is also interesting to compare these polymorphs in context of V-V pairing mechanism, which strongly influences the conductivity pathways. VO₂(*M*1) undergoes V-V dimerization in the monoclinic insulating phase with very short V-V bonds (~2.65 Å) creating a large dimer-to-dimer distance (~3.12 Å)¹⁴. This alternate long and short V-V separation inhibits conductivity. But when VO₂(*M*1) undergoes a phase transition to the rutile structure all the V-V distances become the same (~2.87 Å) and do not allow the formation of dimers¹⁴. In contrast, one doesn't see a significant change of V-V distance in the *B* phase¹⁰. One could plainly see that, even though these VO₂ polymorphs have the same chemical stoichiometry, their structures and electronic attributes

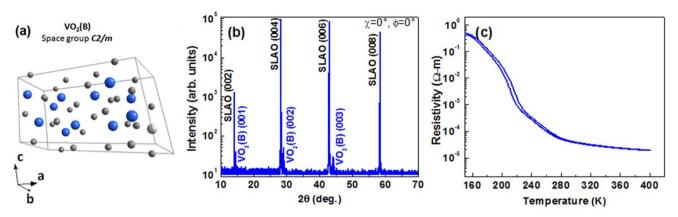


Figure 1 (a) Crystal structure of the VO₂(*B*) polymorph. The vanadium atoms are represented by blue spheres and the oxygen atoms are represented by dark grey spheres.(b) XRD θ -2 θ pattern for the VO₂(*B*) film epitaxially grown on (001) SLAO substrate. (c) Temperature dependent resistivity of VO₂(*B*) on SLAO measured using a traditional four point geometry.

are evidently distinct and a comparative study between these polymorphs is aptly motivated by an objective to get a better understanding on the correlation between MIT and structural phase transition. Furthermore, while a lot of progress has been made towards understanding the physics of metal-insulator transition in VO₂(*M*1) by optical techniques^{17–28}, no parallel efforts has been made so far to understand the mechanism in VO₂(*B*). From a practical applications point of view, one of the key attractions of VO₂(*B*) is that it is conducting at room temperature, compared to VO₂(*M*1) which is insulating and may hold technological merits over VO₂ (*M*1) for devices at room temperature operation⁸.

The drastic changes in conductivity with temperature for these VO₂ polymorphs are accompanied by a corresponding change in optical response, thereby making terahertz (THz) spectroscopy a viable technique to probe the nature of electronic properties in these systems. There have been several reports where THz spectroscopy has been employed to measure conductivity in VO2(M1) polymorphs^{25,26,29-31}. Although metal-insulator transition materials are generally characterized by standard four-point probe method, it provides information only about dc conductivities which can be distorted by surface defects due to electrode contacts³². On the other hand, THz spectroscopy is a contactless probe, providing frequency-dependent complex conductivity in the far-infrared region. Terahertz time-domain spectroscopy (THz-TDS) allows the amplitude and phase of the THz pulse to be obtained, without the need for Kramers-Kronig analysis in the extraction of complex conductivity³³⁻³⁵. Moreover, compared to traditional steadystate dc conductivity measurements which is limited to macroscopic conductivity paths, THz spectroscopy explores electron dynamics over nanometer length scales, possibly revealing conducting phases in this scale undetectable by long-range transport measurements²⁹. Indeed, THz spectroscopy has been used to make comprehensive optical investigations in a host of materials rich in exotic conducting phases including graphene^{36,37}, toplogical insulators^{34,38}, superconductors^{39–41}, oxide semiconductors^{32,33}, quantum-confined semiconductors⁴², and percolating systems⁴³.

In this paper we report a systematic investigation of THz complex conductivities of 60-nm thick $VO_2(B)$ thin films deposited on (001) SrLaAlO₄ (SLAO) substrate. There has been no literature report on the complex conductivities of this system. In our operational THz frequency range (0.3–2.3 THz), there are no observable optical phonon resonances of $VO_2(B)$, and hence it is possible to observe the conductivity response that arises solely from free carriers. These are then compared with that of 60-nm $VO_2(M1)$ thin films deposited on SLAO substrate. This study conclusively demonstrates clear signatures of different electronic orders in these two vanadium dioxide polymorphs.

Results

Sample growth, structural and transport characterization. The XRD spectra of VO₂(*B*) thin film on SLAO is shown in Figure 1(b). We clearly see that the XRD reflections of VO₂(*B*) are perfectly aligned with the substrate (azimuthal angle, $\chi = 0$). This means that our film is highly oriented. Temperature-dependent electrical transport measurements are carried out in Physical Property Measurement system (Quantum Design) utilizing a four probe geometry. As shown in Figure 1(c), the resistivity of VO₂(*B*) films grown on SLAO substrate undergo four orders-of-magnitude change (from $2 \times 10^{-5} \Omega$ -m to 0.35 Ω-m) in resistivity as the temperature changes from 400 K to 160 K, which is consistent with a previous report on VO₂(*B*) nanorods⁸. There is a weak thermal hysteresis at low temperatures below 240 K.

THz-TDS. Figure 2(a) shows time-domain signal of the main THz pulse [E(t)] transmitted through the film and reference for VO₂(*B*) thin film. After the main pulse, a weaker pulse (etalon pulse) appears due to multiple reflections in the substrate. The main THz pulse and etalon pulse are well separated in the time domain, allowing easy truncation of the time-domain data to remove the etalon pulse. All our subsequent data analysis is done on the main pulse and removal of etalon pulses does not lead to any relevant loss of information. The lower panel of Figure 2(a) is the THz absorption at 295 K by plotting the difference in the electric field time domain signal between the sample and the reference $[\Delta E(t)]$. Fast Fourier Transform (FFT) is then performed on the THz transmission spectra.

The transmittance, $T(\omega)$ of the VO₂ film is defined as the ratio between complex electric field of the THz pulse from sample (film + substrate) $\tilde{E}_s(\omega)$ and reference (bare substrate) $\tilde{E}_r(\omega)$. In Figure 2(b) the frequency-dependent and temperature-dependent transmittance amplitudes through the VO₂(*B*) film are shown. In the insulating state, at temperatures lower than the transition temperature, we find that the transmittance amplitude is close to unity. For VO₂(*B*) film, as the temperature of the sample approaches ~240 K, there is THz absorption and a clear trend of increasing absorption at higher temperatures. The spectral shape is almost frequency independent for all runs. The frequency dependent complex refractive index $\tilde{n} = n + i\kappa$ can be extracted from the experimental transmittance $T(\omega)$ by fitting the formula^{36,44}

$$T(\omega) = \frac{2\tilde{n}(\tilde{n}_{sub}+1)\exp\left[\frac{i\omega(\tilde{n}-1)}{c}\right]\exp\left[-\frac{i\omega\Delta L(\tilde{n}_{sub}-1)}{c}\right]}{(1+\tilde{n})(\tilde{n}+\tilde{n}_{sub})+(\tilde{n}-1)(\tilde{n}_{sub}-\tilde{n})\exp\left[\frac{2i\omega d\tilde{n}}{c}\right]}$$
(1)

where \tilde{n} and \tilde{n}_{sub} are the complex refractive indices of VO₂ film and SLAO substrate, respectively, *d* is film thickness and ΔL is the thickness



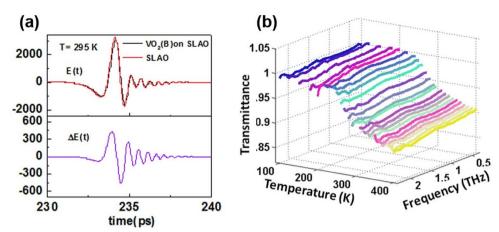


Figure 2 (a) THz signals transmitted through VO₂(*B*) film deposited on SLAO substrate compared to the transmitted signal through bare substrate at 295 K shown along with monoclinic VO₂(*B*) cell. While the top panel describes the raw transmitted THz electric-field waveform E(t) the bottom panel represents the corresponding difference in the THz waveform $\Delta E(t)$ between the sample and the reference. (b) Evolution of the transmission spectra with temperature and frequency of VO₂(*B*) thin film deposited on SLAO substrates during warming process.

difference between sample and reference substrates and c is the speed of light in vacuum. This above equation takes into account the multiple internal reflections inside the film.

The extracted complex refractive index \tilde{n} is then used to calculate the complex optical conductivity $\tilde{\sigma} = \sigma_1 + i\sigma_2$ where $\sigma_1(\omega) = 2n\kappa\omega\varepsilon_0$ and $\sigma_2(\omega) = (\varepsilon_{\infty} - n^2 + \kappa^2)\omega\varepsilon_0$ where ε_0 is the permittivity of free space and ε_{∞} is the high frequency dielectric constant. For VO₂(*B*), ε_{∞} is an unknown quantity and is initially set to 1. After the determination of complex conductivities, ε_{∞} will be used as a temperature-dependent fitting parameter in the conductivity models as discussed in the following sub-sections. On the other hand, we used $\varepsilon_{\infty} = 9$ based on previous studies for determining conductivities in VO₂(*M*1)^{45,46}.

Complex conductivity of VO₂(*B*). The complex optical conductivities of the VO₂(*B*) films for temperatures ranging from 240 K to 400 K are shown in Figures 3(a) and (b) as a function of frequency during the

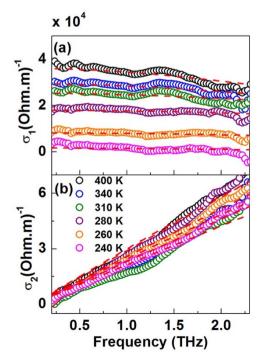


Figure 3 | (a) Real and (b) imaginary conductivities in the THz frequency range of $VO_2(B)$ thin films grown on SLAO with fits to the Drude model (red dash lines) shown for temperatures ranging from 240 to 400 K.

warming process (open symbols). Below 240 K, the transmission is ~100%, giving zero real conductivity, indicating that the films are clearly insulating. The onset of a positive $\sigma_1(\omega)$ marks the transition from an insulating regime to a conducting one. We clearly observe $\sigma_1(\omega)$ to increase with increasing temperature throughout our frequency range. Thermal excitation of electrons into the conduction band can account for this nature, that is, a Drude response where $\sigma_1(\omega)$ is a maximum at low frequency and decreases with increasing frequency, while $\sigma_2(\omega)$ are zero at low frequency and increases with increasing frequency.

According to the Drude model, the frequency dependent complex optical conductivity is given by

$$\tilde{\sigma} = \frac{s_0 \omega_P^2}{\gamma - i\omega} - i\varepsilon_0 \omega (\varepsilon_\infty - 1) \tag{2}$$

where ω_P is the Drude plasma frequency, γ is the free carrier scattering rate and ε_{∞} is the high frequency dielectric constant as defined earlier. Both $\sigma_1(\omega)$ and $\sigma_2(\omega)$ at each temperature measurement are simultaneously fitted to Equation 2, as shown by the dash red lines in Figures 3(a) and (b) respectively. The fits are reasonably good for all temperatures. The fittings results of the Drude parameters are shown in Figures 4(a) and (b). The simultaneous fitting of $\sigma_1(\omega)$ and $\sigma_2(\omega)$ to the Drude model greatly reduces the width of the error bars of the fitted γ and ω_P even though $\sigma_1(\omega)$ is relatively featureless.

We observe a similar trend in both the plasma frequency and the scattering rate – both parameters increases as we increase the temperature up to ~280 K, and tends to saturate beyond 280 K. This common trend in ω_p and γ describe two different temperature-dependent conductivity mechanisms. To address this issue and to make a distinction, we describe the temperature regions 240 K $\leq T \leq$ 280 K and 280 K $\leq T \leq$ 400 K as conductivity regimes I and II respectively.

In regime I, $\omega_P/2\pi$ rises from (8 ± 1) THz to (49 ± 8) THz, while in regime II this parameter has a mean value of $\sim (54 \pm 5)$ THz. The plasma frequency is closely related to the number of charge carriers (N) in the system via $\omega_P^2 = Ne^2/m^*\varepsilon_0$ where m^* is the effective mass. The scattering rate, (γ) is associated with the mobility of the carriers, (μ) via the expression $\gamma = e/(m^*\mu)$. Without the knowledge of the carriers' effective mass, accurate values of N and μ in VO₂(B) cannot be determined. In the later sub-sections, more discussions regarding the nature of m^* will be presented.

The Boltzmann dc conductivity σ_0 can be obtained from the expression

$$\sigma_0 = \frac{\varepsilon_0 \omega_P^2}{\gamma} \tag{3}$$

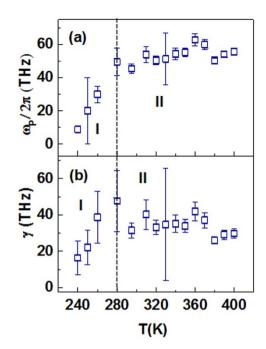


Figure 4 | Temperature dependence of (a) the plasma frequency and (b) the scattering rate, for $T \ge 240$ K as estimated from the Drude fitting. The dashed lines are guide to the eye demarcating the two different electronic orders.

Figure 5(a) shows the calculated dc conductivity using Equation 3. The plot shows σ_0 increasing with increasing temperatures, but the rate of change is significantly smaller at higher frequencies. We recall that while ω_P and γ start saturating at 280 K, σ_0 does not. However, for T > 280 K and $T \le 280$ K, σ_0 changes with different slopes and hence can be correlated with our description of conductivity regimes I and II. If we compare, our estimated dc conductivity from the THz measurements are consistent with the electrical transport measurements shown in Figure 1(c). Figure 5(b) shows the logarithmic conductivity, $\ln(\sigma)$ plotted against reciprocal temperature, 1000/T. The activation energy, E_a can be estimated from the thermal activation model of dc conductivity which has the following temperature dependence

$$\ln\sigma = A - \frac{E_a}{k_B T} \tag{4}$$

where $k_{\rm B}$ is the Boltzmann constant. The linear fittings of the conductivity regimes with the activation model show a good agreement. Fits to Equation 4 yields E_a (regime I) = (260 \pm 30) meV, and E_a (regime II) = (47 ± 3) meV. This significant difference in activation energies supports our claim that there are two different temperature dependent conductivity mechanisms in $VO_2(B)$. In regime I, the conductivity mechanism is poor with larger activation energy, while in regime II, the conductivity is better with smaller activation energy. The presence of small activation energy in conductivity regime II shows that even at high temperatures it has not achieved a fully metallic state. The features of metal-insulator transition in $VO_2(B)$ can be understood as follows: (i) Temperatures below 200 K can be identified as a pure insulating state displaying 100% transmission in the insulating state, (ii) conducting state I is an intermediate electronic phase transition characterized by strong dependence of Drude parameters with temperature, (iii) conducting state II describes the phase after the transition is completed. The boundaries of various electronic phases driven by temperature are thus more clearly defined in the THz-TDS study compared to the electrical transport measurements where the change in resistivity is gradual and not well discernible.

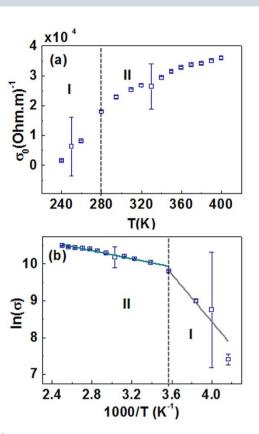


Figure 5 | (a) Temperature dependence of dc conductivity of $VO_2(B)$ films on SLAO as estimated from Equation 3. (b) Logarithmic plot of conductivity $\ln(\sigma)$ vs reciprocal temperature 1000/T shown alongside linear fitting and the conductivity regimes I and II.

Comparison with VO₂(M1). The THz conductivity spectra of 60-nm thick VO₂(M1) film grown on SLAO are shown in Figure 6 plotted as the temperature of the system is gradually increased from 343 K to 400 K. In contrast to VO₂(B), throughout this temperature range, $\sigma_1(\omega)$ increases with increasing frequency, while $\sigma_2(\omega)$ starts at zero at low frequencies, becomes negative, then crosses over to positive with increasing frequency. This is consistent with the previous reported THz studies of VO₂(M1) films^{25,26,30}.

In classical VO₂(*M*1) systems it has been reported that the complex conductivities can be effectively modelled by Drude-Smith theory, which is a generalisation of the Drude model proposed by Smith, in order to account for the conductivity suppression due to charge localization^{33,43,47,48}. In this polymorph, it is widely considered that the transition from a highly transparent insulating phase to an absorbing metallic phase occurs through a percolating network^{29,46,49}. Near the threshold of this transition, phase separation and domain formation dictate the electronic pathways. The frequency-dependent optical conductivity in the Drude-Smith model is given by⁴⁷

$$\tilde{\sigma} = \frac{\varepsilon_0 \omega_P^2}{\gamma - i\omega} \left[1 + \sum_j \frac{c_j \gamma}{\gamma - i\omega} \right] - i\varepsilon_0 \omega (\varepsilon_\infty - 1) \tag{5}$$

The additional terms described by c_j represents the fraction of the carrier's initial velocity retained after *j* number of scattering events⁴⁷. In various systems such as poor conductors, metal-insulator transition materials and various nanomaterials where the Drude-Smith model is successfully applied, only the first scattering term is considered (i.e. j = 1)^{30,48,50–52}. In this scenario, carrier transport transitions from ballistic to diffusive after one scattering event, leading to complete momentum randomization⁴⁷. In our fitting analysis also we will only consider the first c_j term and in this case we take $c_1 = c$. The parameter *c* can take up any values anywhere between 0 (free Drude

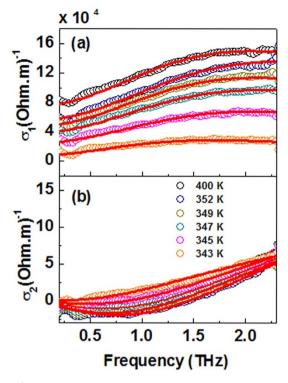


Figure 6 (a) Real and (b) imaginary conductivities of $VO_2(M1)$ films on SLAO with fits to the Drude-Smith model (sold red lines) for six selected temperature points in the range 343 K–400 K during the warming process.

carrier conduction) and -1 (full carrier backscattering)⁴³. There have been other reports of using effective medium theory (EMT) models to fit THz conductivities of VO₂(*M*1) with varying degrees of success^{29,31}. Our attempts to model the optical conductivities using the effective medium models gave inconsistent results (Supplementary Information). On the other hand, as shown by the fitting lines in the Figures 6 (a) and (b), the Drude-Smith formalism given by Equation (5) when j = 1 gives excellent fits to our measured conductivities of $\sigma_1(\omega)$ and $\sigma_2(\omega)$. We could see that even at high temperatures the conductivity does not follow an ideal Drude behaviour which indicates that the nanogranular boundaries persist even after the transition. In highly granular systems, the Drude-Smith is much more effective in describing the effective conductivity rather than a conventional EMT models because it can describe effective conductivities of systems where grain boundaries persist even in large conducting fractions^{30,43}. The advantage of Drude-Smith over EMT models in this scenario has been discussed by T. L. Cocker *et.al*³⁰.

Simultaneous complex fitting of optical conductivities gives the information about the parameters $\omega_{P_0} \gamma$ and *c*. Figure 7 summarizes the $\omega_{P_0} \gamma$ parameters obtained from the fitting procedure as well as the dc conductivity σ_0 which is given by the equation, $\sigma_0 = \varepsilon_0 \omega_P^2 (1 + c)$

 $\frac{\varepsilon_0 \omega_P^2 (1+c)}{\gamma}$. The Drude-Smith parameters ω_P and γ increase with increasing temperatures in the temperature range 343 K–349 K; above 349 K they remain largely temperature-independent. This characteristic is similar to the temperature dependence of Drude parameters in VO₂(*B*). In the temperature range 352 K–400 K, the mean value of $\omega_P/2\pi$ is ~ (110 ± 4) THz. The fitting parameter *c* lies between -0.88 and -0.75 which indicates significant carrier back-scattering – an attribute of carrier localization, resulting in significant suppression of low-frequency conductivities. The temperature dependence of the fitted values of *c* supports the percolation picture in VO₂(*M*)⁴³.

We find that similar to ω_P and γ , σ_0 increases with increasing temperatures till 349 K; at higher temperatures, it attains a mean saturating value of (6.5 \pm 0.3) \times 10 4 (Ohm.m) $^{-1}$. Analogous to $VO_2(B)$, we can define the temperature range of 343 K-349 K as conductivity regime I and 352 K-400 K as conductivity regime II. However in VO₂(*M*1), σ_0 remains largely temperature independent in conductivity regime II, while in $VO_2(B)$ there is a weak temperature dependence in this regime. Figure 7(d) shows the linear fitting plot of logarithmic conductivity, $\ln(\sigma)$ versus reciprocal temperature, 1000/T. Similar to our previous analysis of VO₂(*B*), we can determine the activation energy of $VO_2(M1)$ from the slope of the linear relation. For $VO_2(M1)$, in the low-temperature regime I, the activation energy $E_a = (2200 \pm 500)$ meV while in the high-temperature state II, $E_a = (20 \pm 8)$ meV. The difference between the activation energies in regions I and II is much larger in $VO_2(M1)$ than in $VO_2(B)$ which is consistent with our ω_P and σ_0 results where the quantitative growth of these values as the system goes from regime I to II is much larger in $VO_2(M1)$ compared to $VO_2(B)$. Also, while the activation

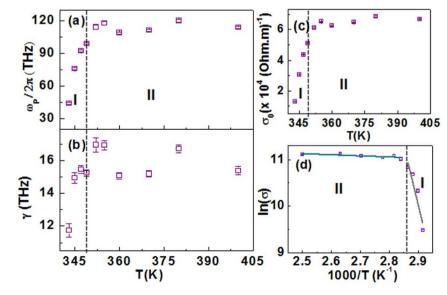


Figure 7 | Temperature dependence of Drude-Smith fitting parameters: (a) the plasma frequency, $\omega_P/2\pi$ (b) the scattering rate, γ for $T \ge 343$ K and (c) dc conductivity as estimated from Equation 3 for VO₂(*M*1) films grown on SLAO during the warming cycle. The dashed lines separates the conductivity regimes I and II. (d) Logarithmic conductivity, $\ln(\sigma)$ dependence on reciprocal temperature 1000/*T* is shown and fitted with a linear relation.

energies in regime II are similar in these VO₂ polymorphs, E_a of VO₂(*M*1) is an order of magnitude larger than that of VO₂(*B*) in regime I. This means that in regime I, the conductivity slope is steeper in VO₂(*M*1) and concomitantly we found a sharper rise of ω_P and γ in VO₂(*M*1) in regime I.

According to M. M. Qazilbash et. al.22, a significant enhancement of the carrier effective mass, m^* (as large as $5m_e$, where m_e is mass of an electron) is found in the infrared spectra, especially in the intermediary phase transition state which is analogous to our conductivity regime I. After the transition is completed (at $T \sim 350$ K), m^* is close to $2m_{e}$ which is the value reported by other experiments⁴⁶. Considering $m^* = 2m_e$, at temperatures just above the transition (T = 352 K), we obtain the carrier density to be $\sim 3.6 \times 10^{20} \text{ cm}^{-3}$ from the plasma frequency. In the case of Drude-Smith model, the relationship between γ and μ is modified as, $\gamma = \frac{(1+c)e}{m^*\mu}$. This relationship gives $\mu = 11.35 \text{ cm}^2/(\text{V} \cdot \text{s})$ at T = 352 K in VO₂(M1). Previous THz-TDS experiments on VO₂(M1) reported similar values of carrier density and mobility^{30,31}. Hall effect measurements reported similar values of carrier density at this temperature but the reported mobility is lower, which is probable as THz study does not face the challenges in Hall measurements due to low-mobility⁵³. The fundamental difference between these two techniques is that while Hall measurement is meant for DC conductivity measurements THz-TDS is an AC measurement method. Hall measurement being a contact method requires the charge carriers to travel substantial distance across the biased electrodes but on the other hand THz-TDS captures the conductivity traversed in sub-pico second timescales resulting in 'conductivity snap-shots'42. As a consequence, THz-TDS can give conductivity information before the carriers are trapped or recombined and as such it is quite reasonable to expect that the THz mobility would be higher than the Hall mobility. We can also compare the carrier density and the mobility parameters of $VO_2(M1)$ with that of $VO_2(B)$. By assuming $m^* = 2m_e$ at T = 295 K for $VO_2(B)$, which is just after the transition, the calculated values are $N \approx 6.4 \times 10^{19} \text{ cm}^{-3} \text{ and } \mu \approx 21.9 \text{ cm}^2/(\text{V} \cdot \text{s}).$

It has been reported that the first-order phase transition in $VO_2(M1)$ takes place via percolation where metallic domains embedded in a matrix of insulating phase starts nucleating sporadically as temperature is increased. When the temperature reaches the metalinsulator transition temperature T_{MI} , the domains become well connected to form a percolating path in this inhomogeneous composite medium. The Drude-Smith model has been applied to various percolating systems where inhomogeneity in conductivity contributes of

a non-zero backscattering parameter *c*. On the other hand VO₂(*B*) can be described by a simple Drude model, although it is a poor conductor in comparison to VO₂(*R*). The fact that VO₂(*R*) cannot have an ideal Drude behavior can be explained by its granular origin, intrinsic inhomogeneity. In VO₂(*B*) we cannot see evidence of inhomogeneous phase separation or percolating transport from the THz study and thus shows a good Drude fit. The explanation for this difference between the polymorphs is two-fold — first, VO₂(*B*) is a more uniform film in the context of epitaxial growth with lesser roughness and hence no backscattering. VO₂(*M*1) on the other hand, has a more grainy morphology due to the larger β inter-axial angle (Supplementary Information). Second, the activation energy is larger in VO₂(*B*) in the conducting state and so the number of thermally activated carriers are smaller.

Furthermore, the narrow intermediate state of $VO_2(M1)$, which falls in our conductivity regime I, is a strongly correlated phase marked by enhanced mass and an optical pseudo-gap before crossing over to a rutile metallic state as indicated by several optical measurements including infrared spectroscopy, ellipsometry and femtosecond pump-probe measurements^{22,23,49,54}. It is also possible that in the intermediate state of $VO_2(B)$, electronic correlations may play a significant role in this intermediate transition state. The rich electronic phase diagram of these vanadium dioxide polymorphs can be summarized from our THz transmission spectra as illustrated in Figure 8.

Discussion

In conclusion, we have used THz spectroscopy to measure the temperature-dependent complex optical conductivity of vanadium dioxide polymorphs. In our operational frequency range (0.3–2.3) THz, $VO_2(B)$ exhibits no phonon modes and the onset of Drude conductivity behaviour arrives for temperatures higher than 240 K. On the other hand, in $VO_2(M1)$ the THz conductivity can be better described by the Drude-Smith model. Key parameters of carrier dynamics (i) plasma frequency (ω_P) and (ii) scattering rate (γ) are obtained by fitting to the Drude (in $VO_2(B)$) and Drude-Smith in (VO₂(M1)) models. Interestingly, our THz analysis revealed that like in $VO_2(M1)$, $VO_2(B)$ also transforms from an insulating system to a conducting system but is mediated by a much broader intermediate state with the transition onset much closer to room temperature making it more suitable than the widely studied $VO_2(M1)$ for optoelectronic devices operating at room temperature. Our study also demonstrates that these polymorphs can also be used as temperature-controlled THz frequency modulators. While the sharp phase

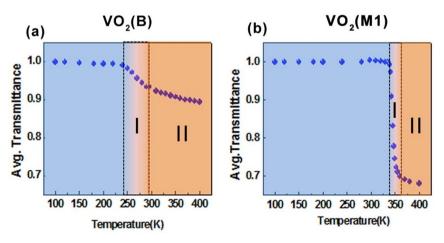


Figure 8 Normalized and frequency-averaged THz transmission of (a) $VO_2(B)$ and (b) $VO_2(M1)$ thin films as a function of temperature during the warming process. These values are normalised to the transmission at 100 K. The blue colour regions represent the insulating phases while the pure conducting phases are coloured orange. The two dotted lines mark the intermediate transition state. The conductivity regimes I and II as described in the previous discussions are also labelled.

Methods

Sample growth. Pulsed Laser Deposition is used to fabricate the various VO₂ polymorph thin films by ablating a commercial Vanadium single crystal (100) orientated target on the SLAO (001) substrate. The growth temperature is 500°C and the oxygen pressure is varied from 5×10^{-3} to 7×10^{-3} Torr. By systematic control of oxygen growth pressure and pulse laser frequency, the various phases of VO₂ are stabilized. Detailed growth conditions study has been reported in a previous study⁵⁶.

XRD and AFM. The θ -2 θ diffraction data measurements are done on a Bruker D8 Discover diffractometer CuK_{α1} ($\lambda = 1.54$ Å). Temperature-dependent electrical transport measurements are carried out in Physical Property Measurement system (Quantum Design) utilizing a four probe geometry. The surface morphology analysis of the various films are characterized on an atomic force microscope (AFM, Dimension V, Veeco).

THz-TDS. THz transmission spectra measurements of the VO₂ films are carried out using the TeraView Spectra 3000 THz-TDS system, incorporated with a Janis ST-100-FTIR cryostat. The operational temperature range of the cryostat is 10 K to 450 K. In this system low temperature-grown GaAs films is used for the generation and detection of THz waves. THz time-domain data of VO₂ films are taken with respect to the signal transmitted through the bare substrate as a reference. Optical properties of the bare SLAO substrate are determined by THz-TDS, with vacuum as the reference signal. The complex refractive index, \tilde{n}_{sub} of SLAO substrate is obtained to be $\tilde{n}_{sub} \approx 4.1 - 0.004i$ and almost temperature and frequency-independent, and thus is a very suitable THz transparent material in our operational temperature and frequency range. The cryostat is equipped with a vertical motorized stage with a resolution of 2.5 µm which is used to control the back and forth motion between the sample and reference positions.

The aperture diameter used is 7 mm which allowed for an accurate measurement of the THz signal for frequencies as low as 0.3 THz. For each sample and reference run, 900 THz traces are taken in 3 minutes. The thickness difference between the film substrate and the bare substrate (reference), must be taken into account in our subsequent analysis⁵⁷. The sample is kept in a high vacuum ($\sim 10^{-6}$ mbar) for all our experiments.

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Author contributions

T.V. and E.E.M.C. conceived the project. J.L., T.V. and E.E.M.C. designed the research and E.E.M.C. supervised the project. A.S. fabricated the samples and conducted electrical measurements. H.R. took X.R.D. measurements. J.L. performed the AFM measurements. THz-TDS data were taken by J.L. and C.L. and analyzed by J.L. and E.E.M.C. The manuscript was prepared by J.L. and E.E.M.C. with assistance from T.V., C.L. and A.S. All the authors contributed to discussion on the results for the manuscript.

Additional information

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